



Recent Advances in Micro/Nano-Fabrication

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Deadline for manuscript
submissions:

closed (30 September 2024)

Message from the Guest Editors

In recent decades, micro/nano-fabrication technologies have been widely used to prepare non-destruction testing transducers, semiconductors, special functional surfaces, and medical interventional key components. These kinds of micro/nano-fabrication technologies include traditional cutting/dicing, laser machining, micro-3D printing, printed circuits, chemical machining, and optical machining. Micro/nano-fabrication technologies are the key factors with which to determine the functions of micro/nano-devices. We are pleased to invite you to submit your recent research papers and reviews on the micro/nano-fabrication, construction, performance, and functional integration of microdevices, as well as their multiple applications. This Special Issue aims to collect and present the recent advances in micro/nano-fabrication, as well as provide deep insights for future works. In this Special Issue, original research articles and reviews are welcome. Research areas may include (but not limited to) micro/nano-materials and processing as well as related engineering and technology.

I/We look forward to receiving your contributions.





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Message from the Editor-in-Chief

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